

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Kazutaka KOBAYASHI

Serial No. 10/537,863

Group Art Unit: 3742

Confirmation No. 7195

Filed: June 6, 2005

Examiner: Maria Alexandra Elve

For: METHOD OF FORMING VIA HOLE IN RESIN LAYER

RESPONSE

Mail Stop Amendment

Commissioner for Patents

PO Box 1450

Alexandria, VA 22313-1450

Sir:

This is in response to the Office Action mailed April 1, 2009, which has a period for response set to expire on July 1, 2009.

The following remarks are respectfully submitted. Reconsideration of the claims is respectfully requested.

A list of the claims begins at page 2; and

Remarks begin at page 4.